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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/718,828	11/21/2003	Michael Kozhukh	042390.P11082D	1333
7590 11/12/2004			EXAMINER	
Michael A. Bernadicou			NGUYEN, HUNG	
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP Seventh Floor			ART UNIT	PAPER NUMBER
12400 Wilshire Boulevard Los Angeles, CA 90025			2851	
			DATE MAILED: 11/12/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

)		Me	_
	Application No.	Applicant(s)	_
	10/718,828	KOZHUKH, MICHAEL	
Office Action Summary	Examiner	Art Unit	
	Hung Henry V Nguyen	2851	_
The MAILING DATE of this communication a Period for Reply	appears on the cover sheet with	the correspondence address	
A SHORTENED STATUTORY PERIOD FOR REF THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a r - If NO period for reply is specified above, the maximum statutory peri - Failure to reply within the set or extended period for reply will, by sta Any reply received by the Office later than three months after the ma earned patent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, however, may a replication of the statutory minimum of thirty (3 od will apply and will expire SIX (6) MONTH tute, cause the application to become ABAN	y be timely filed 30) days will be considered timely. S from the mailing date of this communication. IDONED (35 U.S.C. § 133).	
Status		•	
 1) ⊠ Responsive to communication(s) filed on Pr 2a) ☐ This action is FINAL. 2b) ☒ T 3) ☐ Since this application is in condition for allow closed in accordance with the practice under 	his action is non-final. wance except for formal matter	s, prosecution as to the merits is	
Disposition of Claims			
4) ☐ Claim(s) <u>26-31</u> is/are pending in the applica 4a) Of the above claim(s) is/are withd 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) <u>26-31</u> is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and	rawn from consideration.		
Application Papers			
9) The specification is objected to by the Examination The drawing(s) filed on 21 November 2003 is Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the	s/are: a)⊠ accepted or b)⊡ o he drawing(s) be held in abeyance rection is required if the drawing(s)	e. See 37 CFR 1.85(a). is objected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the priority docume application from the International Bure * See the attached detailed Office action for a limit of the certified copies of the priority docume application from the International Bure * See the attached detailed Office action for a limit of the certified copies of the priority documents.	ents have been received. ents have been received in App riority documents have been re eau (PCT Rule 17.2(a)).	olication No eceived in this National Stage	
Attachment(s)	" □	(070 440)	
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date <u>11/03</u>. 		nmary (PTO-413) Mail Date rmal Patent Application (PTO-152)	

U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Application/Control Number: 10/718,828

Art Unit: 2851

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 26-31 are rejected under 35 U.S.C. 102(e) as being anticipated by Sandstrom et al (U.S.Pat. 6,624,880).

With respect to claims 26-30, Sandstrom et al discloses an micro lithography and corresponding method comprising all of the limitations of the instant claim such as: providing a reflective liquid crystal display (30) having an array of configurable pixels (col.3, lines 54-60); functioning as a mask for forming any predetermined patterns including a first image pattern and a second pattern on the reflective liquid crystal display; a radiation (10) for directing radiation from a radiation source onto the reflective liquid crystal display thereby generating a first and second reflected radiation patterns/or generating a continuously varying reflected radiation pattern (see col.7, lines 38-49, lines 55-59 and col.8, lines 1-10); a projection optical system

Art Unit: 2851

(col.5, lines 38-63) for reducing and projecting the first and second reflected radiation patterns onto a substrate (60).

As to claim 31, Sandstrom et al further disclose the radiation source being an optical light source, an ultraviolet light source, an excimer laser, an x-ray source, an electron source, or an ion source (see col.7, lines 50-59).

Prior Art Made of Record

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Lin (U.S.Pat. 6,215,578); Marle (US 2002/0171816 A1) and Fries (U.S.Pat. 6,544,698) discloses Maskless pattern generation photolithography system and have been cited for technical background.

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Henry V Nguyen whose telephone number is 571-272-2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

^VHung Henry V Nguyen Primary Examiner

Art Unit 2851

hvn 11/6/04